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SERIAL NUMBER 10/820,781	FILING OR 371(c) DATE 04/09/2004 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 0756-7289
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APPLICANTS

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**** CONTINUING DATA ******* None

**** FOREIGN APPLICATIONS ******* JAPAN 2003-116391 04/21/2003

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 06/19/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 5	TOTAL CLAIMS 47	INDEPENDENT CLAIMS 8
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature <i>Harold Chan</i>	Initials <i>ST</i>		

ADDRESS

31780

TITLE

Beam irradiation apparatus, beam irradiation method, and method for manufacturing semiconductor device

FILING FEE RECEIVED 1816	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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